



Date: 2013-03-29
 Scan Range: 500.0 nm to 800.0 nm
 Comments: 49019_Zeiss Axio_2-8_Mounted
 ET Cy5 Longpass
 ET620/60x ET665lp T660lpxrt
 Set Lot: C-154623 Qty: 1

— 260775 — 263880 — 263309

Description
 ET620/60x
 ET665lp
 T660lpxrt

Lots / Filepath
 260775
 263880
 263309

ORIENTATION

Proper orientation of this filter is necessary in order to minimize autofluorescence and maximize performance. Please take a moment to locate the caret (arrow) located on the edge of each filter.

Excitation (x) filters should be positioned with the caret pointing toward the specimen and the inside of the cube, and away from the light source.

Emission (m) filters should be positioned with the caret pointing toward the specimen and the inside of the cube, and AWAY from the detector/eye.

Dichroic mirrors (bs) should be mounted with the coated surface TOWARD the light source, excitation filters and specimen. The coated side will be identified with a caret pointing to it, or a bevel. The beveled side is the smaller surface.

CLEANING AND HANDLING FILTERS

Handle coated pieces by the edges only. Clean gently only if necessary. Loose particles should be removed with a bulb puffer or filtered, pressurized air cleaner. If necessary, gently wipe surface using anhydrous alcohol and lint free lab towels. Use a new surface of towel with each wipe.

AVOID TOUCHING OR WIPING A/R COATED OR METAL MIRROR SURFACES

AVOID HANDLING EXPOSED COATINGS WITH BARE FINGERS



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